

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 6, 2025

IGI Report Number

LG725506126

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

HEXAGONAL MODIFIED STEP CUT

Measurements

16.13 X 7.85 X 5.54 MM

GRADING RESULTS

Carat Weight

5.71 CARATS

Color Grade

F

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence


NONE

Inscription(s)

 LG725506126

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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
Symmetry

EXCELLENT

Fluorescence

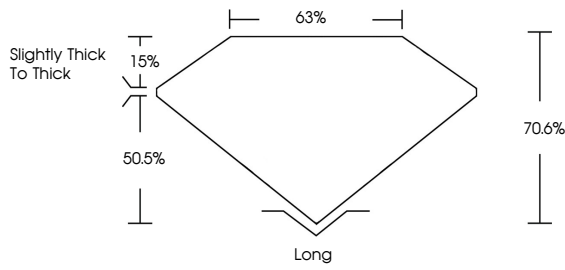
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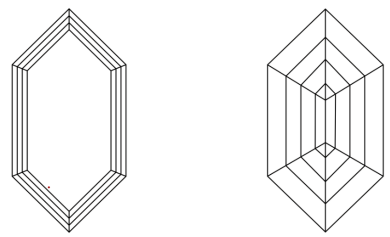
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PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



COLOR

D E F G H I J Faint Very Light Light

CLARITY



IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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HEXAGONAL MODIFIED STEP CUT

16.13 X 7.85 X 5.54 MM

Carat Weight

5.71 CARATS

Color Grade

F

Clarity Grade

VVS 2

Depth

70.6%

Table

63%

Graile

Slightly Thick To Thick

Culet

Long

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

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